

# Reduction and Recovery of Optical Reflectivity of Mo Mirror Irradiated by Low Energy Helium Ions

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Advanced Diagnostics  
for Burning Plasmas

# Purpose and Exp. Procedures

*Radiation effects of He ions on optical reflectivity of Mo at the **first wall relevant conditions** have been studied.*

- To acquire the data of optical reflectivity for wide range of wave length
- To identify the origins of the reduction of reflectivity
- To show the methods to recover the reflectivity

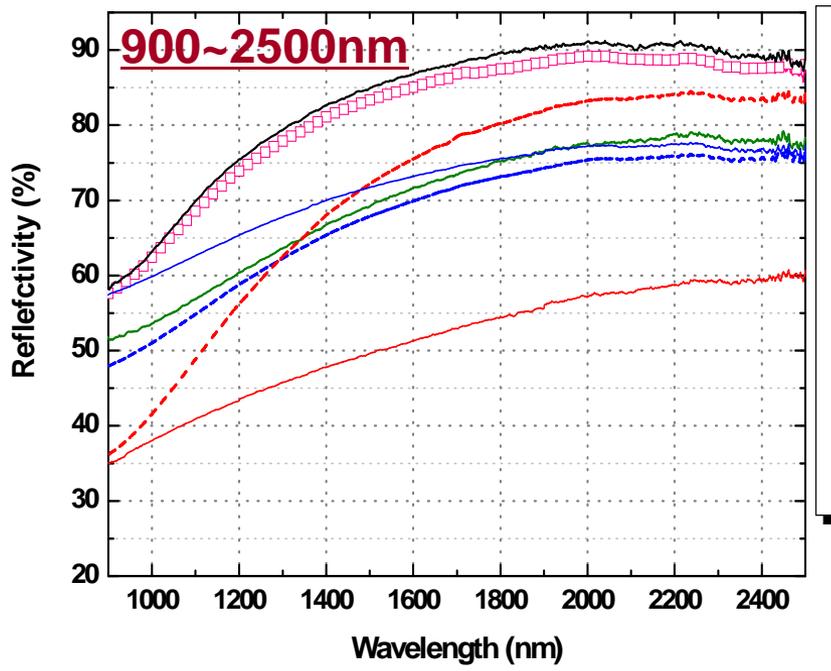
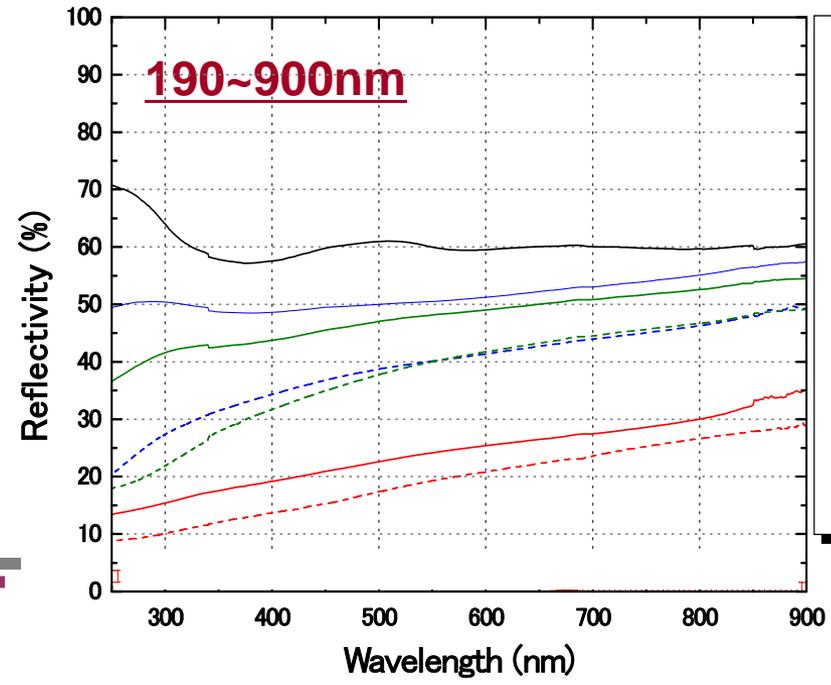
## Irradiation Conditions

- Helium ion energy: **1.2keV, 8keV**
- Irradiation temperature: **300K, 573K, 873K**
- Fluence:  **$3 \times 10^{21} \sim 3 \times 10^{22} / \text{m}^2$**

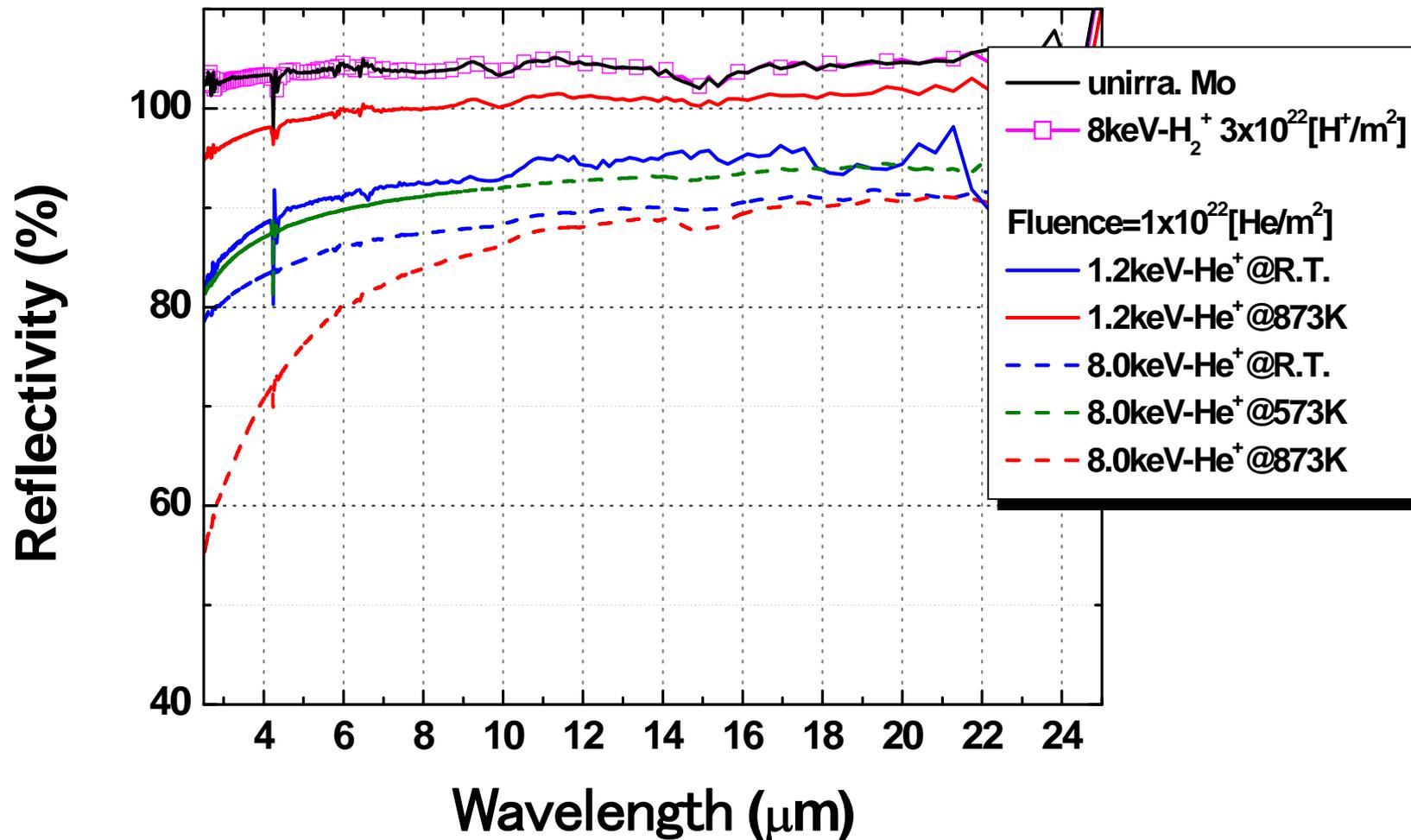
## Post Irradiation Experiments

- Measurements of optical reflectivity at the wide range of wave length (190nm ~ 20 $\mu$ m)
- SEM & AFM observations of surface morphology and roughness
- TEM observation of internal damage structure (top view and cross sectional view)

# Reduction of Reflectivity by He Ion Irradiations at Various Conditions (190~2500nm)

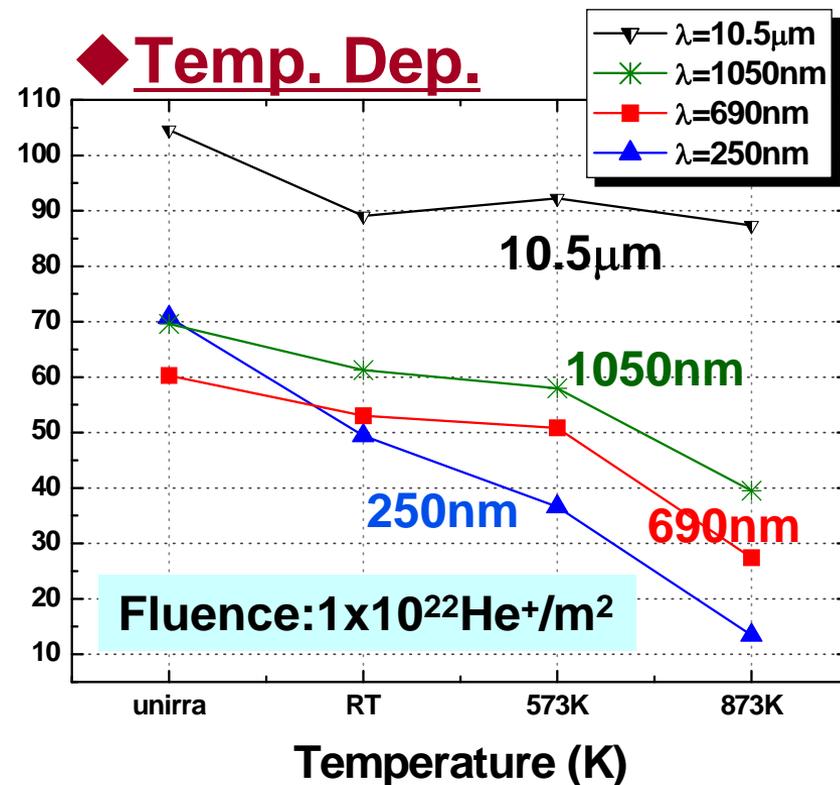
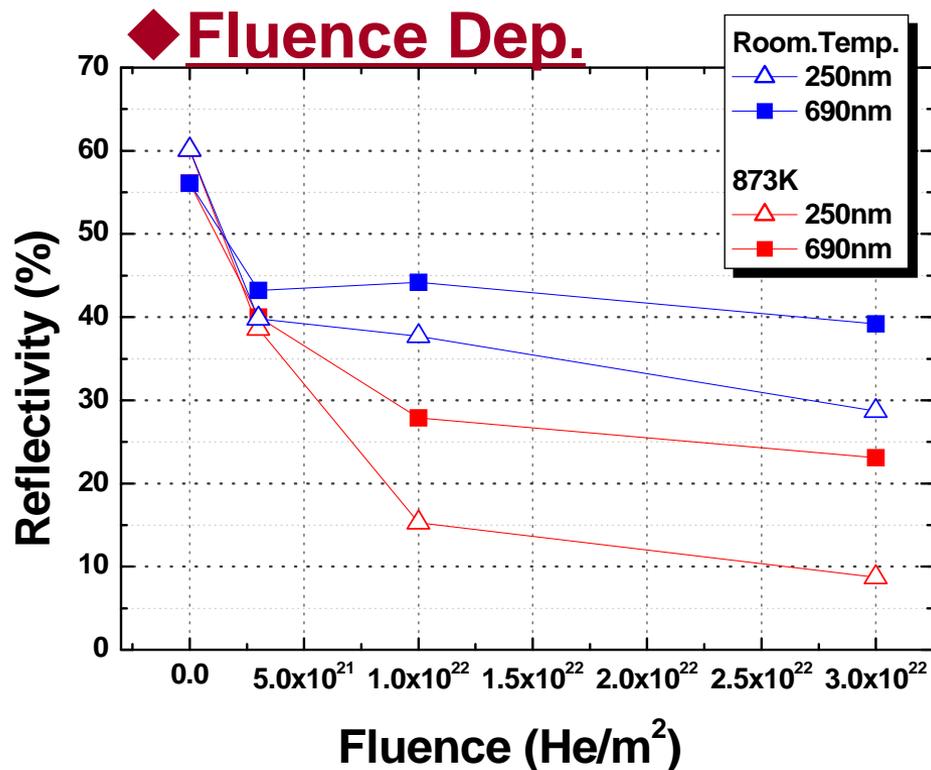


# Reduction of Reflectivity by He Ion Irr. at various Conditions (2.5 $\mu\text{m}$ ~22 $\mu\text{m}$ )



# Fluence and Temp. Dep. of Reflectivity

## Mo, 8keV-He<sup>+</sup>

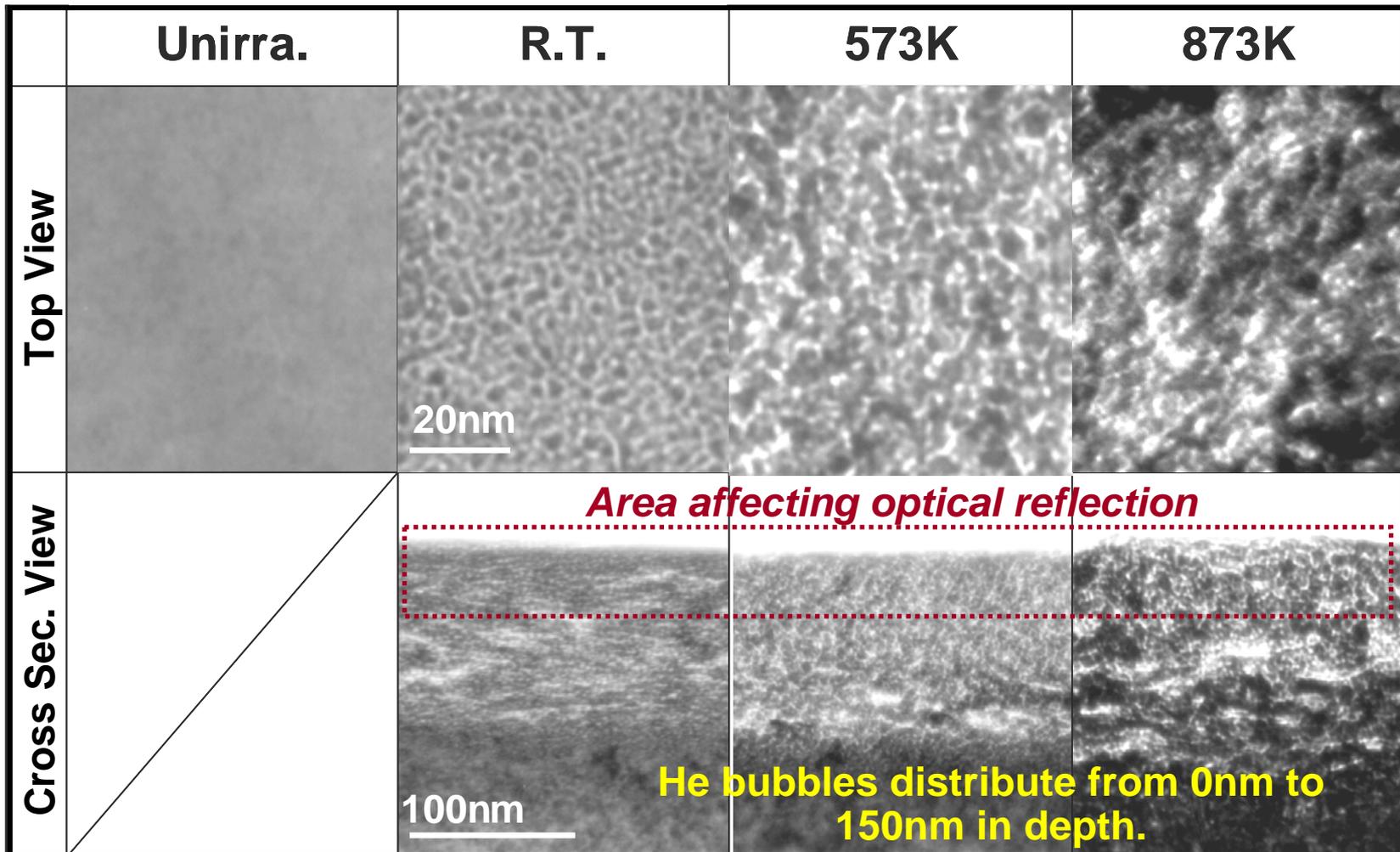


- Remarkable reduction of reflectivity occurs even at low fluence of about 3x10<sup>21</sup>He<sup>+</sup>/m<sup>2</sup>.
- Reflectivity reduces with increasing fluence and irradiation temp..
- The effect is more remarkable at shorter wave length.

# TEM Images Showing Internal Damage

Mo: 8keV-He<sup>+</sup>, 1x10<sup>22</sup>He<sup>+</sup>/m<sup>2</sup>, R. Temp. , 573K, 873K

- At all examined temps. nano-size very dense He bubbles form **porous structure** at the sub-surface region where interaction with light occurs.

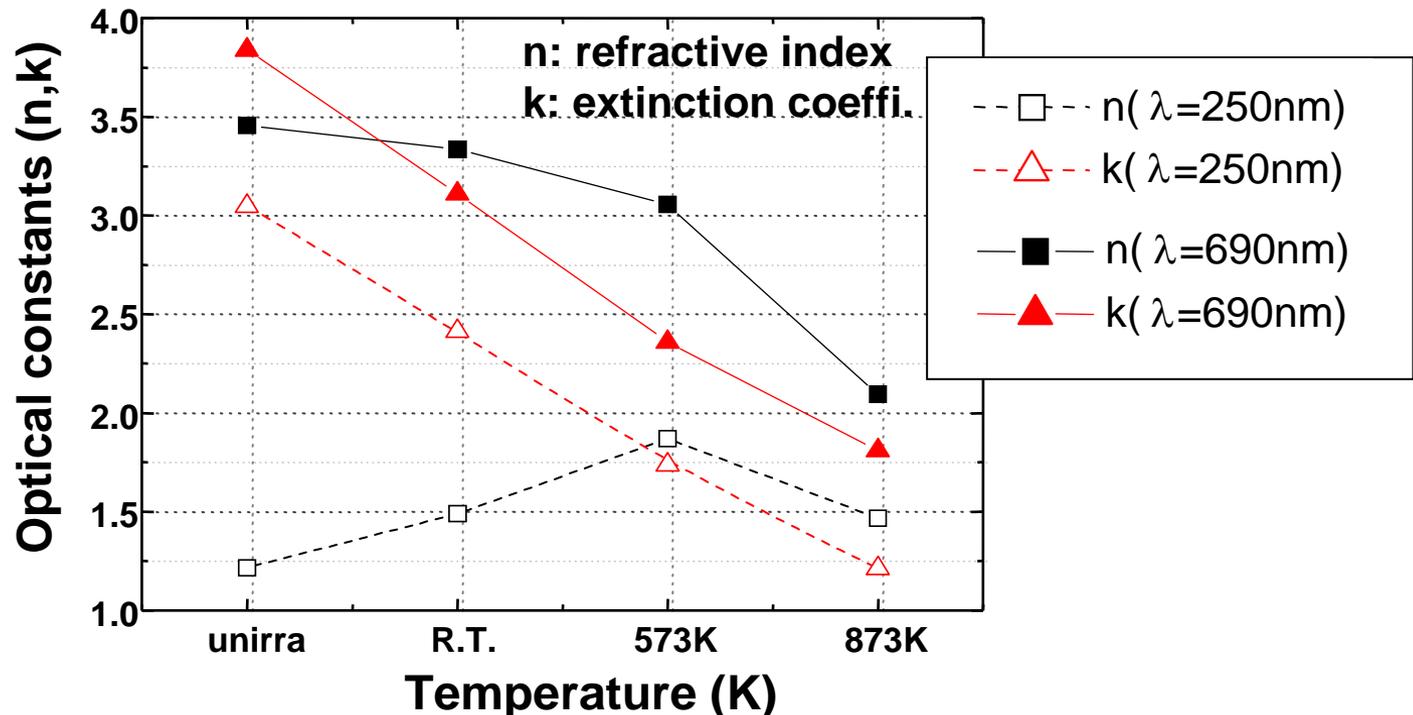


# Refractive Index (n) and Extinction Coeffi. (k)

*n and k were estimated by using an optical ellipsometer.*

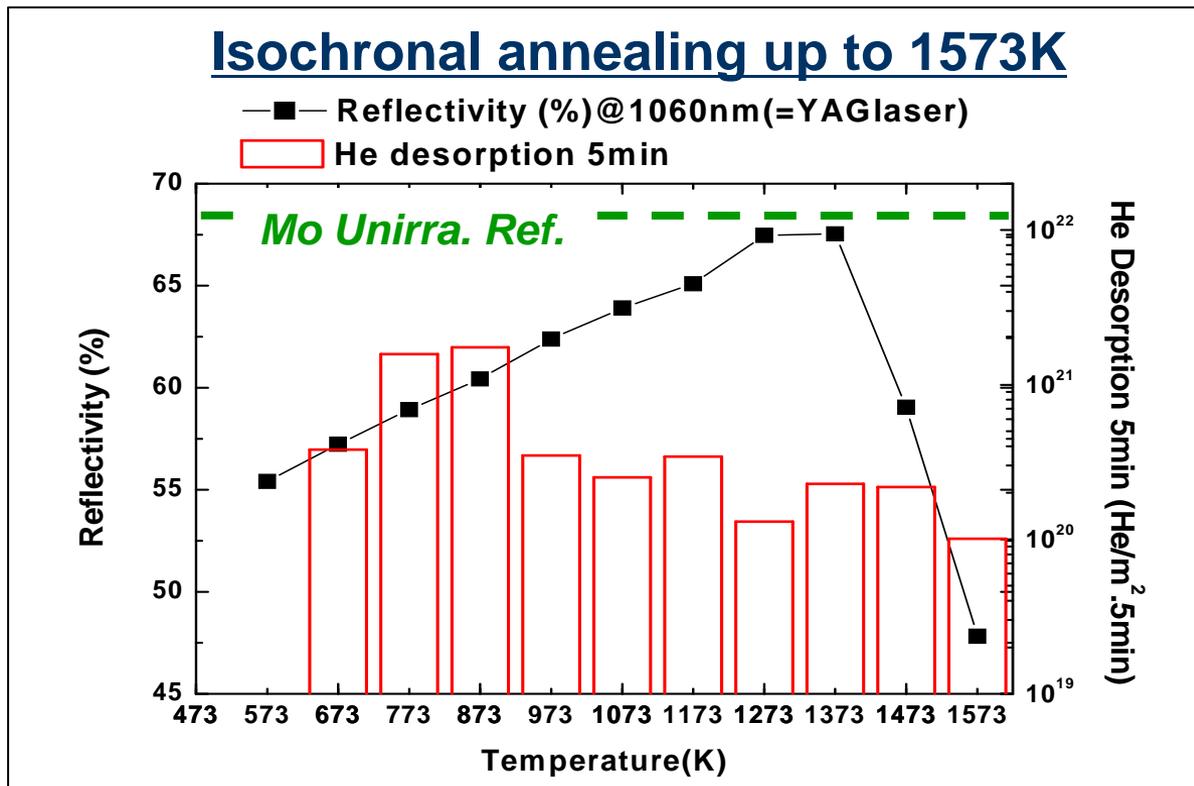
- Reduction of n and k indicates that the material becomes “**dilute**”. This result corresponds well with “**porous structure**” observed by TEM.
- Observed reduction of the optical reflectivity can be roughly explained by using the estimated values of the n and k.
- Detail analysis of the data measured by the optical ellipsometer is on-going.

Mo: 8keV-He<sup>+</sup>,  
1x10<sup>22</sup>He/m<sup>2</sup>,  
R. Temp. ,  
573K, 873K



# Recovery of Reflectivity by Annealing (1)

Mo @573K, 8keV-He<sup>+</sup>, 1x10<sup>22</sup> He<sup>+</sup>/m<sup>2</sup>



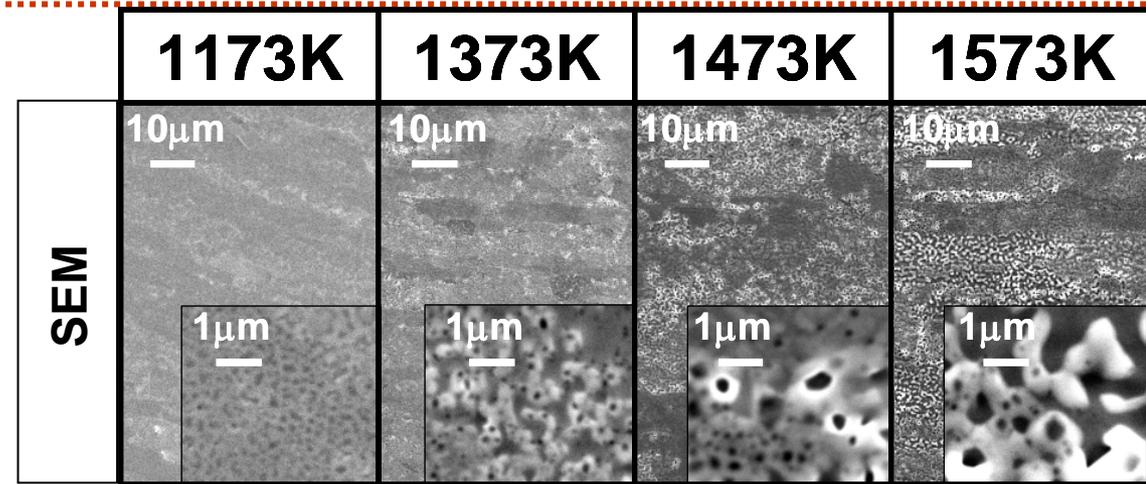
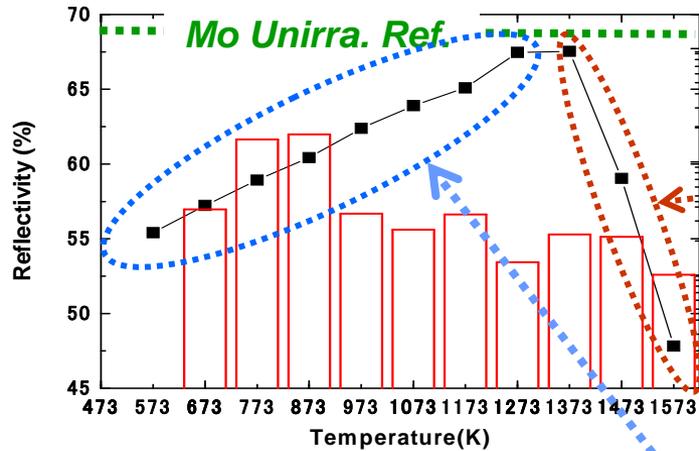
- With increasing annealing temperature, reflectivity increases gradually and **almost recovers at 1273K**. It decreases again at higher temperatures.
- Desorption of injected He, which are mainly trapped in bubbles, occurs during annealing.

To know the reasons, **TEM** and **SEM** observations were carried out.

See Next VG

# Recovery of Reflectivity by Annealing (2)

**Mo @573K, 8keV-He<sup>+</sup>, 1x10<sup>22</sup> He<sup>+</sup>/m<sup>2</sup>**

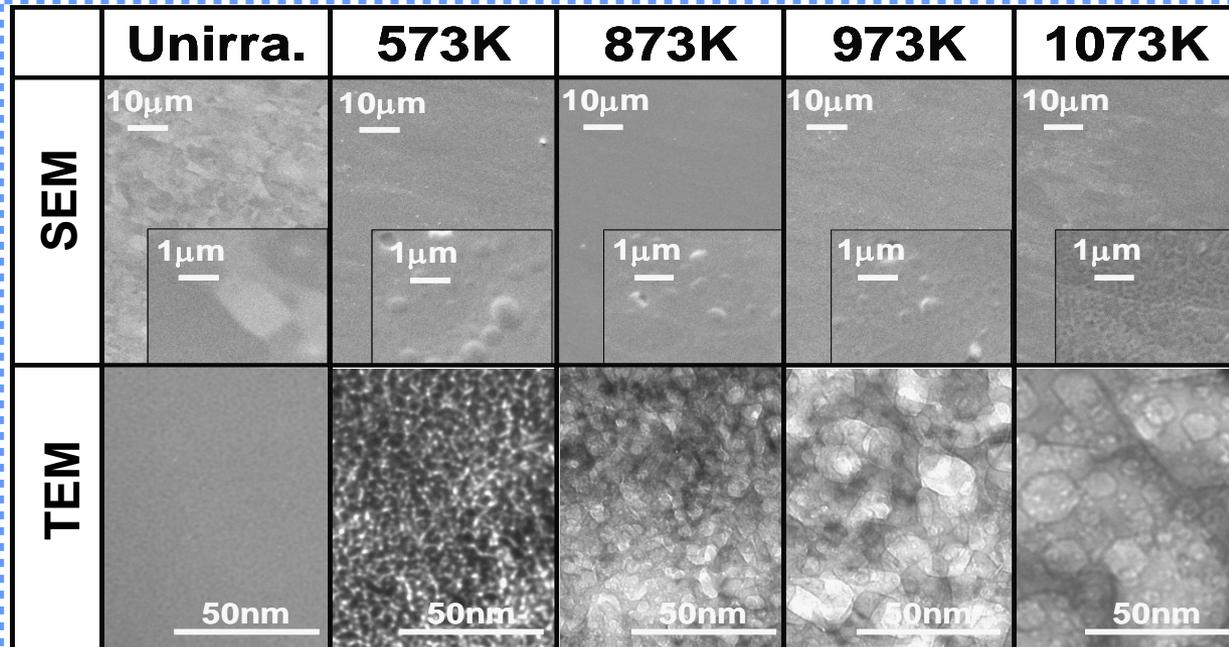


**673K~1273K**

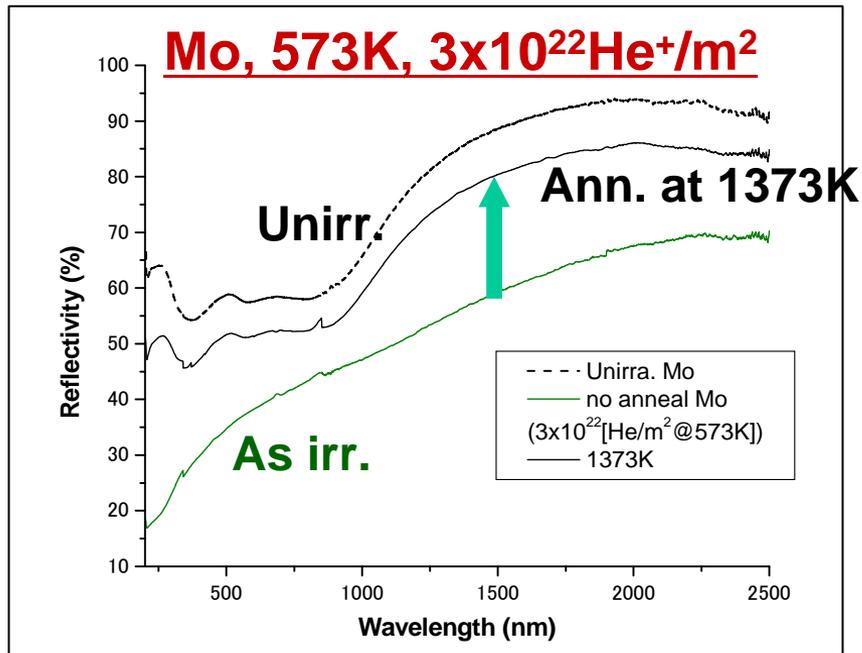
Migration, coalescence and annihilation at the surface of He bubbles.

**1173K~1573K**

Formation of large pin holes at the surface, which causes surface roughening.

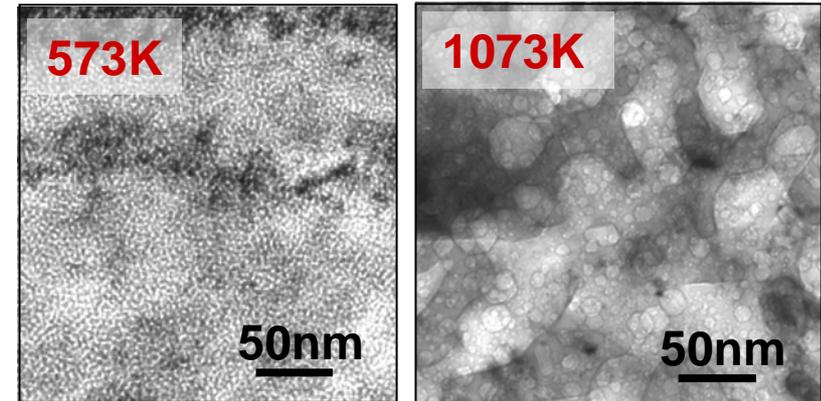


# Recovery Mechanism of Reflectivity by Ann.

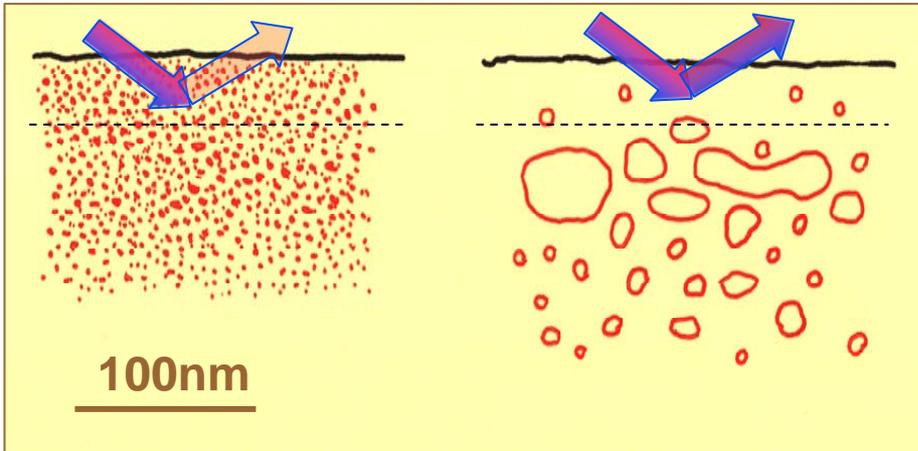


## Recovery of Damage (Isochronal ann.)

Mo @573K, 8keV He<sup>+</sup>,  $1 \times 10^{22} \text{He}^+/\text{m}^2$



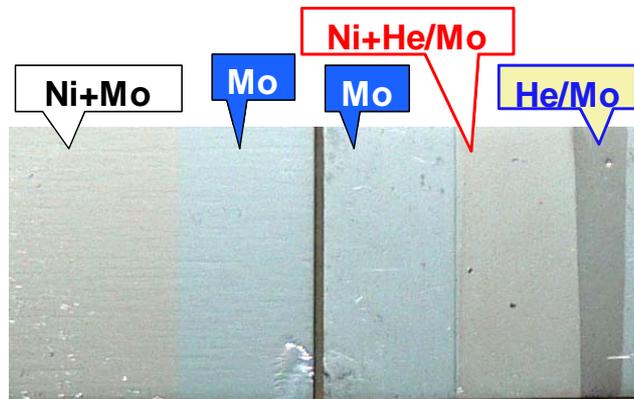
- With increasing temperature, He bubbles become thermally mobile above 673K (start from the smaller ones).
- The mobile He bubbles near the surface disappear preferentially at the surface and result in a **denuded zone of bubbles** at the sub-surface region. Continuous desorption of He suggests coming out of He bubbles at the surface.
- Due to the formation of the **He bubbles free region** at the sub-surface, reflectivity recovers.
- In deeper area, larger He bubbles still remain. At higher temperatures such as 1573K, they aggregate as very large bubbles and finally form  **$\mu\text{m}$ -size pin holes** by reaching the surface.



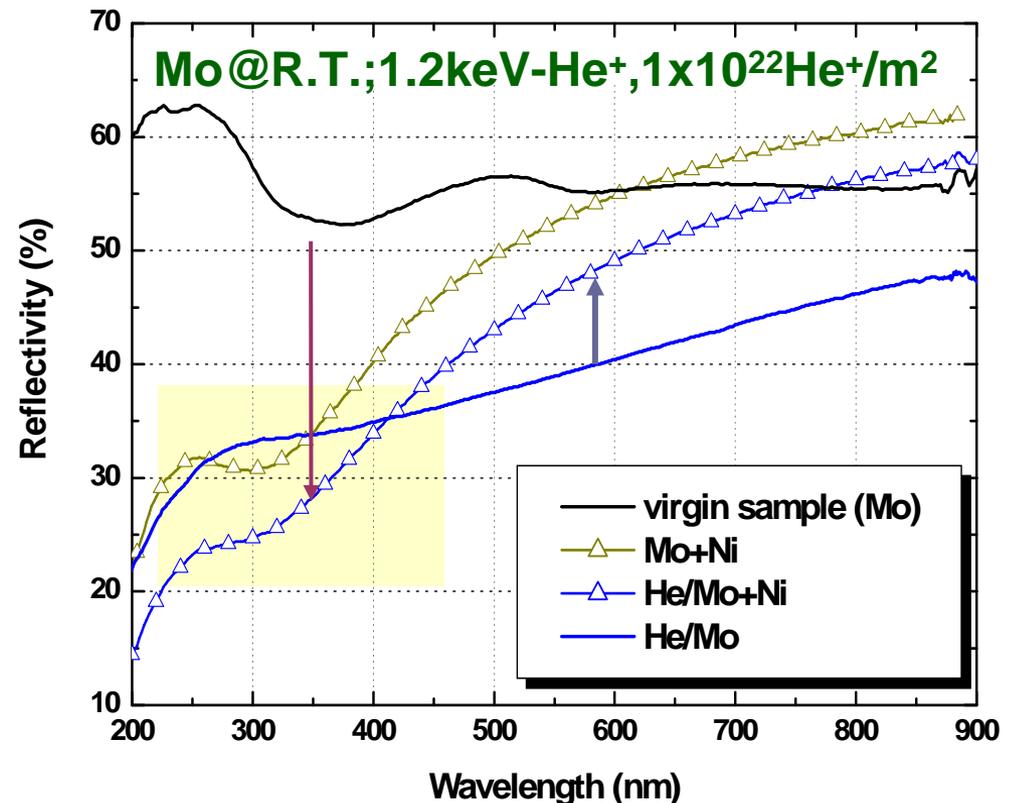
# Recovery of Reflectivity by Metal Deposition

- If the porous structure at the sub-surface region causes reduction of the optical reflectivity, one can expect that the reflectivity can be recovered by depositing thin metallic layer sufficiently thicker than the optical extinction distance.
- **As expected, the reflectivity was recovered by depositing a Ni layer of about 300nm-thick in a vacuum.**

## Effect of Ni deposition



By depositing Ni layer (300nm) on the He irradiated Mo (**Ni+He/Mo**) the reflectivity becomes similar to that of **Ni/Mo**.



# Summary

- Supposing irradiation effect of He particles near the first wall, He irradiation experiments with keV-order energy were performed for well polished Mo at room temperature, 573K and 873K.

- Degradation of the optical reflectivity becomes detectable by the irradiation above  $3 \times 10^{21} \text{He}^+/\text{m}^2$ . Reduction of the reflectivity occurs even in the far infrared region.

- *Origins of Reflectivity Reduction*

- ① Roughening by blistering ( $> \text{keV}$ ,  $< 3 \times 10^{22} \text{He}^+/\text{m}^2$ )
- ② Change of physical properties due to porous structures with fine dense He bubbles. ( $> 10^{22} \text{He}^+/\text{m}^2$ )
- ③ Roughening by  $\mu\text{m}$ -size pin holes (in samples annealed up to 1573K)

- *Recovery of Reflectivity (measures to fine He bubbles)*

- ① Annealing up to 1273K, ② Vacuum deposition of a thin metallic layer

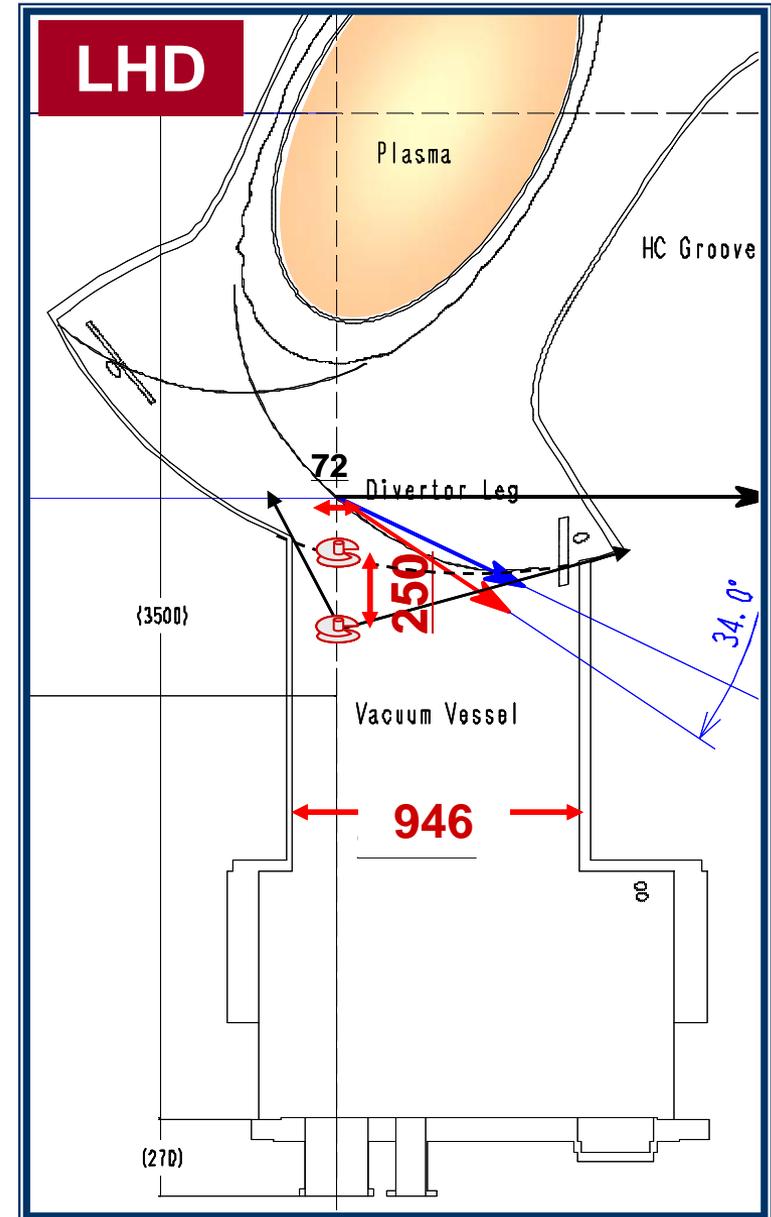
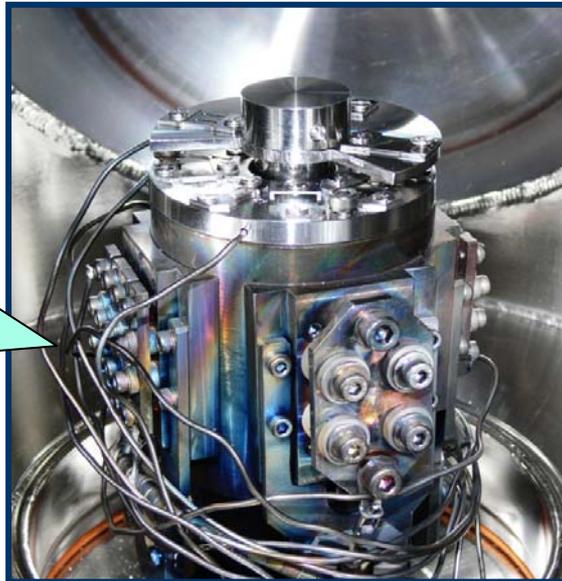
- *Subjects in Near Future*

Synergistic effects of He irradiation and impurity deposition.

# Concerning Damage in Ports of LHD

- In order to estimate the **damage in ports** by plasma particles, **Mo** and **SUS** were exposed to **He plasmas** heated by **ICRF** or **NBI** at the position of **0cm** (wall position), **-5cm** and **-25cm** by using **retractable material probe**.
- Internal damage and optical reflectivity were observed.

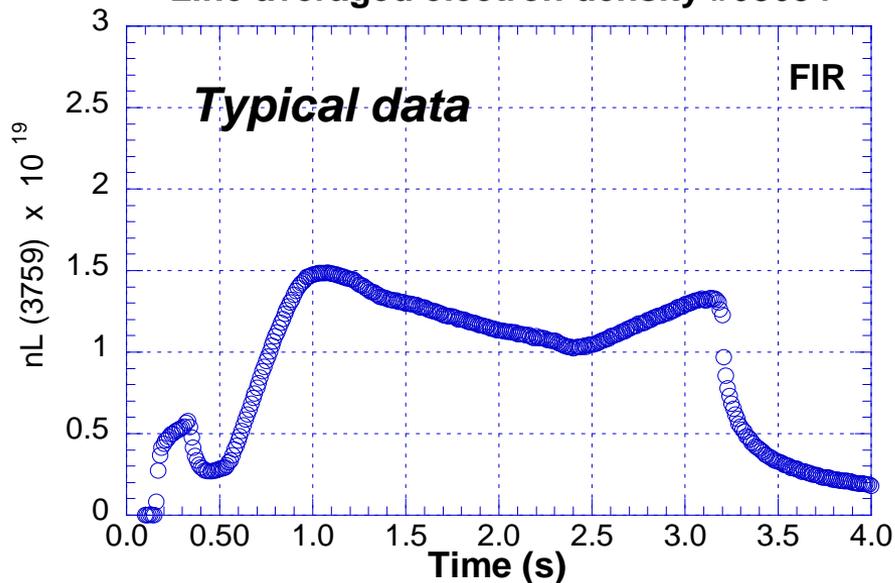
Sample holder of the material probe



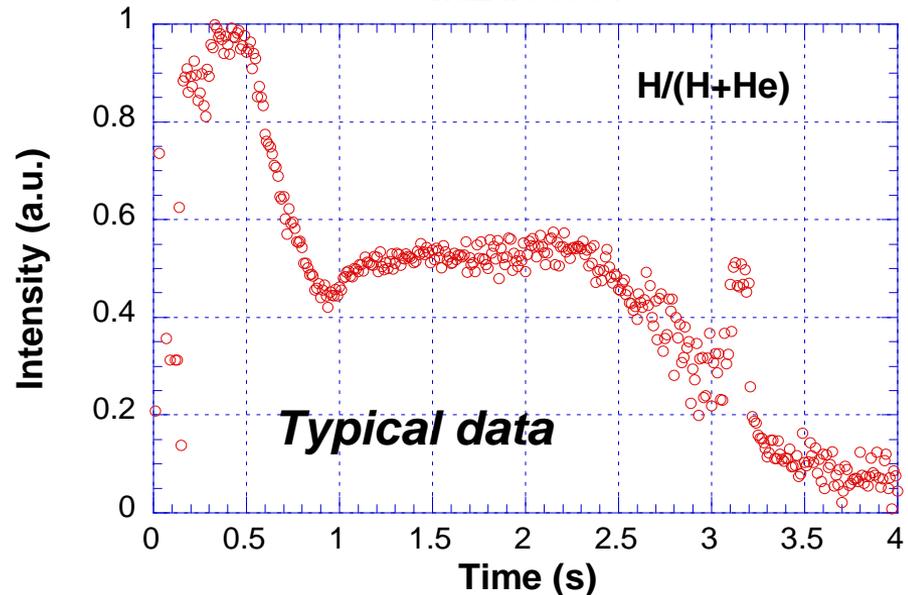
# Discharge Conditions (ICRF)

	position	No. of shots	Discharge time (s)	Ion temp. (keV)	e density ( $\times 10^{19}\text{m}^{-3}$ )	Shot #
(A)	0cm	13	408	0.5~2.0	0.25~3.6	No.68705~68717
(B)	-5cm	81	349.1	0.2~2.0	0.25~2.25	No.68299~68379
(C)	-25cm	86	351.5	0.5~2.0	0.25~3.6	No.68618~68703
(A)+(B)+(C)		185	1138.2	0.1~2.5	0.23~3.85	No.68299~68383, No.68618~68718

Line averaged electron density #68634

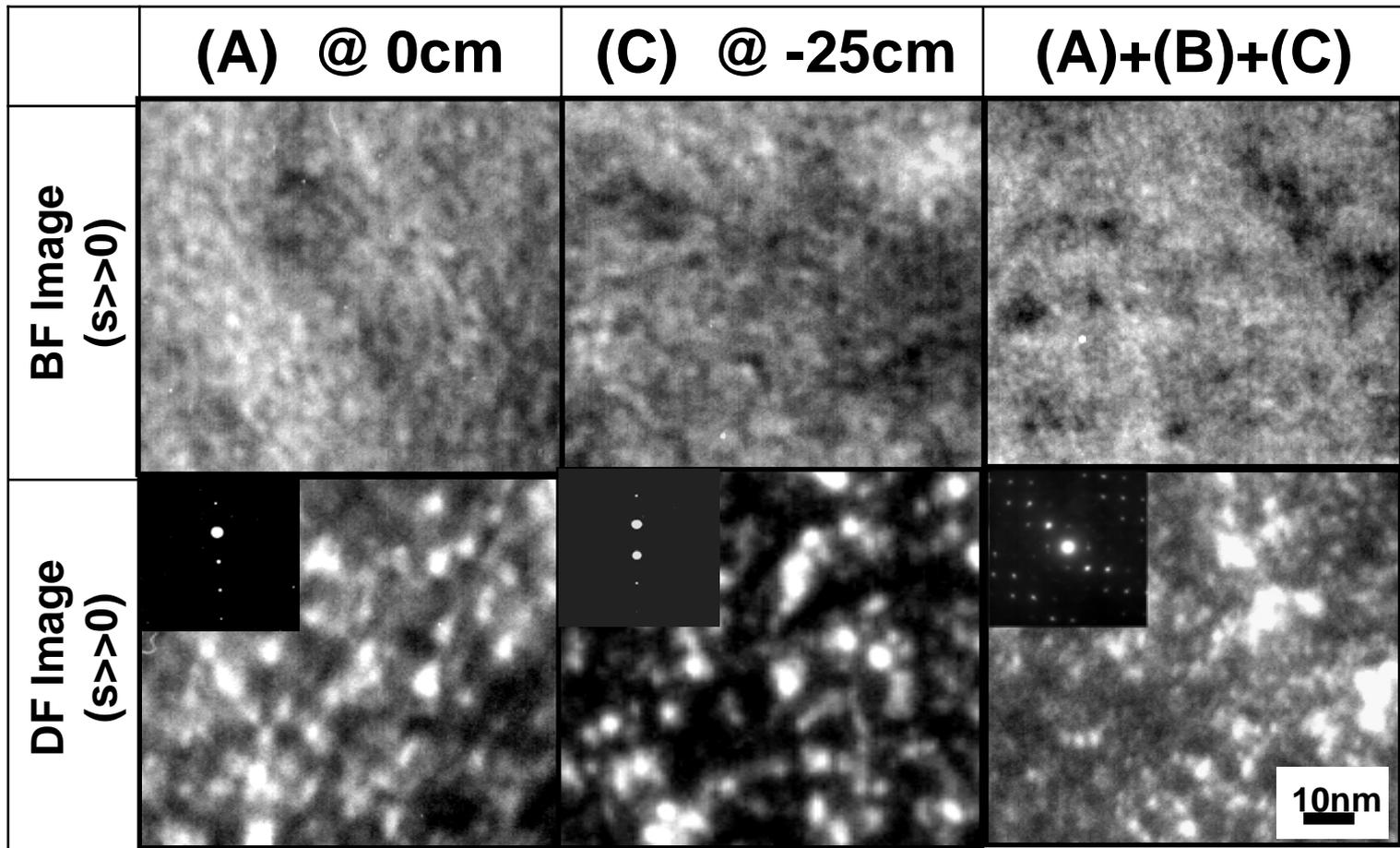


ha2 #68634

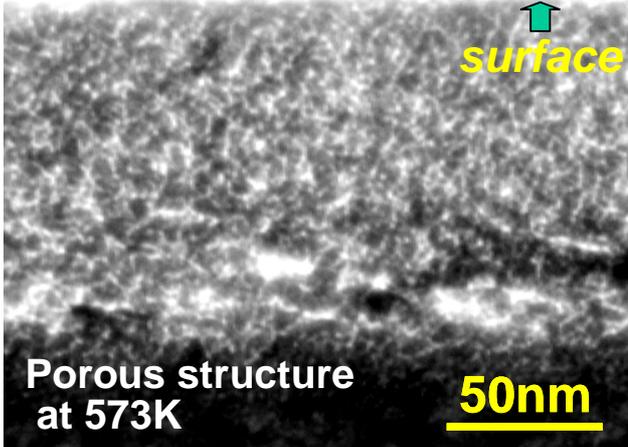
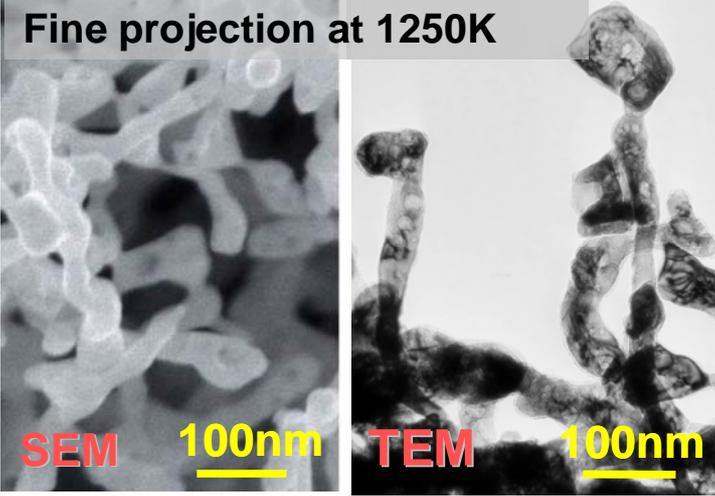


# Damage in Mo Exposed to ICRF-He Plasma

- Even at the position of **-25cm**, serious damage (He bubbles, dislocation loops) occurred like wall position. (exposure time~350s,  $T_i \sim 2\text{keV}$ ,  $n_L \sim 2 \times 10^{19}\text{m}^{-3}$ ). Similar damage was also observed in NBI case.
- This is the damage caused by **CX-He** with energy of about **1keV**. The flux is estimated to be  **$10^{18} \sim 10^{19}\text{He}^0/\text{m}^2\text{s}$** .



# Studies on He Irr. Effects on Optical Reflec.

	1st Wall Relevant Conditions	Divertor Relevant Conditions
Research G.	Yoshida Lab. (Kyushu U.)	Takamura Lab. (Nagoya Univ.)
Material	Mo	W
Irr. Temps.	R.Temp.~873K	1250K~3000K
Ion Energy	1.2keV, 8keV, 14keV	10eV~100eV
Ion Fluence	$\leq 3 \times 10^{22} \text{He}^+/\text{m}^2$	$\leq 4 \times 10^{27} \text{He}^+/\text{m}^2$
Mechanism of Blacking	<ul style="list-style-type: none"> <li>•Blistering</li> <li>•Porous structure by nm-size He bubbles</li> </ul>	<ul style="list-style-type: none"> <li>•Fine projections (a few 10nm<math>\phi</math>) at 1250K</li> <li>•Projections (a few 100nm<math>\phi</math>) and pin holes (~1<math>\mu\text{m}\phi</math>) above 1500K</li> </ul>
Micro-structure	<p>Cross sectional view</p>  <p>Porous structure at 573K</p> <p>50nm</p>	<p>Fine projection at 1250K</p>  <p>SEM 100nm TEM 100nm</p>

**Behavior of He bubbles determines these variety of microstructures and resulting optical properties.**